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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naoyuki KOBAYASHI et al.

Group Art Unit: 2882

Application No.: 10/588,297

Examiner: M. ASFAW

Filed: August 2, 2006

Docket No.: 128977

For: EXPOSURE APPARATUS, EXPOSURE METHOD, AND METHOD FOR  
PRODUCING DEVICE

**SUMMARY OF SUBSTANCE OF INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants' representative Brian K. Kauffman conducted a personal interview with Examiners Asfaw and Glick on June 10, 2011. A summary of the substance of the personal interview is contained in the following remarks.

During the personal interview, independent claims 1, 30 and 74 were discussed. Applicants' representatives explained that the claims are allowable for at least the reasons discussed in the April 26, 2011 Amendment.

Potential amendments to the claims were also discussed during the personal interview.

Should the Examiner believe that anything further would be desirable in order to place this application in even better condition for allowance, the Examiner is invited to contact the undersigned at the telephone number set forth below.

Respectfully submitted,



Mario A. Costantino  
Registration No. 33,565

Brian K. Kauffman  
Registration No. 63,199

MAC:BKK/jia

Date: June 21, 2011

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 320850**  
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